-1-

ONS00181 09/802,726

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hadizad et al.

Serial No.:

09/802,726

Filing Date:

March 12, 2001

Group Art Unit:

2813

Examiner:

Schillinger, Laura M

Title:

SEMICONDUCTOR COMPONENT AND METHOD

OF MAKING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE, ATTN EXAMINER Laura M. Schillinger, AT THE FAX NO. (703) 872-9318

Date of Facsimile Transmission James Stipanuk Name of Person Signing Certificate

Honorable Commissioner of Patents, Washington, D.C. 20231

FAX RECEIVED

2003 MAR 4

TECHNOLOGY CENTER 2800

AMENDMENT

SIR:

In response to the office action mailed 12/04/2002, please amend the above-identified application as follows.

03/11/2003 JDADE1 00000002 501086

09802726

01 FC:1202 02 FC:1201

144.00 CH 84.00 CH

F-171

FAX TRANSMITTAL FORM



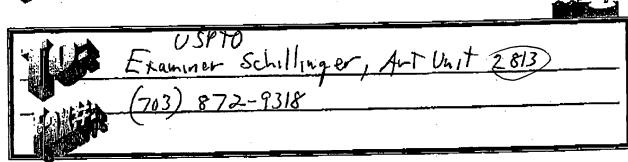
ON Semiconductor

5005 East McDowell Road Phoenix, AZ 85008



anes Stipanuk Tel. (602) 244-5603

Intellectual Property Department Facsimile 602-244-3169



Application Number-09/802,726 FAX RECEIVED Docket Number-04500181 MAR 4 2002 14 pages of Amendment 1 cover page

TECHNOLOGY CENTER 2800

NUMBER OF PAGES INCLUDING THIS COVER PAGE:

ATTENTION: This FAX is intended for the exclusive use of the individual to whom it is addressed and may contain information that is privileged or confidential proprietary. If you a re not the intended recipient, any dissemination, distribution, copying or use is strictly prohibited

If you receive this FAX in error, please notify the sender immediately by telephone and arrange the return or destruction of the information and all copies. Thank you.